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	Application No.	Applicant(s)	
	10/633,909	YEH ET AL.	
Notice of Allowability	Examiner	Art Unit	
	DAVID VU	2818	
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS ( herewith (or previously mailed), a Notice of Allowance (PTOL-85) of NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIG of the Office or upon petition by the applicant. See 37 CFR 1.313	OR REMAINS) CLOSED in this apport or other appropriate communication GHTS. This application is subject to	olication. If not include will be mailed in due	ed course. <b>THIS</b>
1. This communication is responsive to <u>12/08/05</u> .			
2. X The allowed claim(s) is/are 1,2,4-6,9-18 and 20-24.			
3. Acknowledgment is made of a claim for foreign priority under a) All b) Some* c) None of the:  1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have international Bureau (PCT Rule 17.2(a)).  * Certified copies not received:  Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONMITHIS THREE-MONTH PERIOD IS NOT EXTENDABLE.  4. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give  5. CORRECTED DRAWINGS (as "replacement sheets") must	been received in Application No cuments have been received in this re	national stage applicational stage applicational stage application application is deficient.	quirements
<ul> <li>(a)  including changes required by the Notice of Draftsperse</li> <li>1)  hereto or 2)  to Paper No./Mail Date</li> <li>(b)  including changes required by the attached Examiner's Paper No./Mail Date</li> <li>Identifying indicia such as the application number (see 37 CFR 1.5 each sheet, Replacement sheet(s) should be labeled as such in the</li> </ul>	Amendment / Comment or in the O	office action of ags in the front (not the	back) of
6. DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT F	sit of BIOLOGICAL MATERIAL n	nust be submitted.	Note the
Attachment(s)  1. Notice of References Cited (PTO-892)  2. Notice of Draftperson's Patent Drawing Review (PTO-948)  3. Information Disclosure Statements (PTO-1449 or PTO/SB/06 Paper No./Mail Date  4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	5.  Notice of Informal P 6.  Interview Summary Paper No./Mail Dat 7.  Examiner's Amenda 8.  Examiner's Stateme 9.  Other	(PTO-413), e nent/Comment	owance

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## **DETAILED ACTION**

## Reason for allowance

- 1. Claims 1, 2, 4-6, 9-18 and 20-24 are allowed.
- 2. The following is an examiner's statement of reason for allowance:

With regard to method claims 1, 2, 4-6, 9-13 and 24, the prior art of record, either singularly or in combination, does not disclose or suggest at least the claim limitations of "the first and second dielectric layer stacks are formed according to a first and second CVD process respectively, the first CVD process comprises a CVD deposition process comprising at least one of a lower temperature and a higher pressure compared to the second CVD process" as instantly claimed and in combination with the additionally claimed method steps.

With regard to method claims 14-18 and 20-23, the prior art of record, either singularly or in combination, does not disclose or suggest at least the claim limitations of "the first CVD process comprises at least one of a lower deposition temperature and a higher pressure compared to the second CVD process to produce a lower etching resistance in a reactive ion etching process" as instantly claimed and in combination with the additionally claimed method steps.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance".

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## **Conclusion**

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to David Vu whose telephone number is 571-272-1798. The examiner can normally be reached on Monday-Friday 8:00am-5:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on 571-272-1787. The fax phone numbers for the organization where this application or proceeding is assigned is (703) 872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR, Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

DAVID VU PRIMARY EXAMINES